

OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

TAP12 Rec'd PCT/PTO 05 MAY 2006

Application Data Sheet**Applicant Information**

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Syo-ichi
Family Name::	TAKAMIZAWA
City of Residence::	Annaka-shi
Country of Residence::	JAPAN

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Ryuji
Family Name::	SAYAMA
City of Residence::	Annaka-shi
Country of Residence::	JAPAN

Correspondence Information

Correspondence Customer Number::	25944
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Application Information

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None
Title::	METHOD FOR PRODUCING SILICON EPITAXIAL WAFER
Attorney Docket Number::	127101
Suggested Drawing Figure::	1
Total Drawing Sheets::	2
Small Entity::	No

Representative Information

Attorneys associated with Customer No. 25944.

Domestic Priority Information					
Application::	Continuity Type::	Parent Application::	Parent Filing Date::		
This Application is a	National Stage of	PCT/2004/012179	8/25/2004		
Foreign Priority Information					
Country::	Application Number::	Filing Date::	Priority Claimed::		
JAPAN	2003-385333	11/14/2003	Yes		
Assignee Information					
Assignee Name::	SHIN-ETSU HANDOTAI CO., LTD.				
Street of mailing address::	4-2, MARUNOUCHI 1-CHOME, CHIYODA-KU,				
City of mailing address::	TOKYO				
Country of mailing address::	JAPAN				
Postal or Zip Code of mailing address::	100-0005				